



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **NAKATA, Yoshihiro et al.**

Group Art Unit: **2812**

Serial No.: **10/807,174**

Examiner: **VO, Hai**

Filed: **March 24, 2004**

**P.T.O. Confirmation No.: 4205**

**FOR: SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,  
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW  
DIELECTRIC CONSTANT FILM**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 30, 2006

Sir:

In response to the Office Action dated **October 28, 2005, with January 28 and 29 being  
a Saturday and Sunday**, please amend the above-identified application as follows: